

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/437,135

Filed: November 10, 1999

For: SEMICONDUCTOR DEVICE AND METHOD
FOR FORMING THE SAME

)

) Group Art Unit: 2813

) Examiner: Erik J. Kielin

) Confirmation No. 7576

) Date: January 6, 2004

RESPONSE TO SPECIES ELECTION REQUIREMENT

Mail Stop - Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

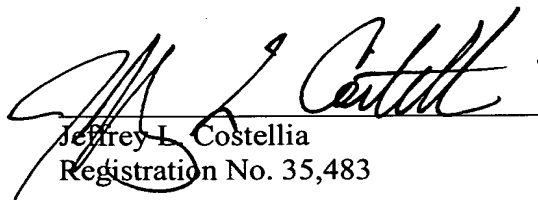
In response to the Restriction Requirement/Election of Species dated
December 10, 2003 applicants respond as follows.

REMARKS

In response to the Office Action of December 10, 2003, Applicants hereby elect
Group II, forming TFTs using two laser annealing steps and readable on claims 1-14 and 29.

Consideration and allowance of the instant application are now respectfully requested.

Respectfully submitted,


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